

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Weimer et al. Art Unit:
Serial No.: Not yet assigned Examiner:
Filed : April 22, 1999
Title : FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES
WITH AN INSULATING FILM USING A WET RAPID THERMAL
OXIDATION PROCESS

JC525 U.S. PTO
09/296835
04/22/99

#5
IOS

6/29/99
AJenkins

Box Patent Application

Assistant Commissioner for Patents
Washington, DC 20231

INFORMATION DISCLOSURE STATEMENT

Applicants submit copies of the references listed on
the attached form PTO 1449.

This statement is being filed with the application.
Please apply any charges or credits to Deposit Account No. 06-
1050.

Respectfully submitted,

Date: 4/22/99

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